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# Gain characteristics of the hybrid slot waveguide amplifiers integrated with NaYF<sub>4</sub>:Er<sup>3+</sup> NPs-PMMA covalently linked nanocomposites

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Waveguide amplifiers based on slot waveguide have enormous capacity due to their ability to confine light strongly to a narrow slot waveguide. NaYF<sub>4</sub>:Er<sup>3+</sup> nanoparticles-polymeric methyl methacrylate covalently linked nanocomposites were synthesized and filled into the slot. The stability and the Er<sup>3+</sup> concentration doped in this novel material were improved. The slot waveguide was designed accurately. The rigorous numerical method, full-vector finite difference method, was used to analyze the modal characteristics and optimize the slot combined with the maximum power confinement in the slot and the minimum effective mode area of the slot. A four-level spectroscopic model pumped at 1480 nm was presented. The rate equations and propagation equations were solved and the gain characteristics of the slot waveguide amplifier were numerically simulated. The primary parameters were optimized. A net gain of 5.78 dB was achieved when the signal power was 0.001 mW at 1530 nm, pump power was 20 mW, Er<sup>3+</sup> concentration was  $1.3 \times 10^{27} \text{ m}^{-3}$ , and the waveguide length was 1.5 cm.

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## Introduction

Silicon photonics have been investigated as the most prospective technology platform for satisfying the high-speed on-chip data communication systems' requirements of low cost, ultra-compactness, and high fabrication compatibility with complementary metal oxide semiconductor (CMOS) technologies.<sup>1,2</sup> Benefiting from previous fruitful research developments, various nanophotonic devices have been proposed for numerous application fields, including micro-ring resonators,<sup>3,4</sup> optical modulators,<sup>5,6</sup> sensors,<sup>7,8</sup> and lasers.<sup>9,10</sup> Despite the outstanding progress that has been achieved over the past few years, the issue of optical loss tends to limit the performance of the on-chip optical interconnected circuits. Silicon waveguide optical amplifiers are vital components for solving the problem of losses in silicon-based optoelectronic devices and the realization of large-scale integration. However, owing to its indirect band gap, silicon is hardly suitable for achieving optical gain.<sup>11</sup> Traditional silicon Raman amplifiers<sup>12</sup> and parametric amplifiers<sup>13</sup> suffer from high pumping power and non-linear losses. The erbium-doped polymer waveguide amplifier has been

proposed as an alternative solution owing to its prominent advantages of simple processing, high bandwidth, low cost, and flexible adjustment of the erbium ion concentration and refractive index.<sup>14,15</sup> Silicon mainly provides a low-loss silicon-on-insulator (SOI) waveguide platform and strong index contrast of the SOI optical waveguides in the hybrid integrated optical waveguide amplifier. Silicon nanophotonic slot waveguides have attracted increasing attention in the photonics community owing to their ability to confine light strongly in a very thin region of a low refraction material.<sup>16,17</sup> In this design, a narrow slot of a low-refractive-index material was sandwiched by two high-index silicon strip waveguides, comprising a slot.<sup>18,19</sup> Owing to the electric displacement continuity boundary condition ( $D = \epsilon E$ ) for the horizontal dielectric interface, the electric field intensity for Quasi-TM polarized light in the vertical medium interface at the sidewall will be modified by the factor of  $n_{\text{Si}}^2/n_{\text{slot}}^2$ .<sup>20,21</sup> Waveguide amplifiers based on the slot waveguide show enormous capacity. An active polymer is filled into the slot as the core layer. This structure with large optical power in the slot can facilitate interactions between the optical field and the polymer. As a result, the slot waveguide amplifiers can achieve high gain with low threshold pump power owing to their small effective mode area. In recent years, slot waveguide amplifiers based on erbium-doped polymer materials have not been reported and only the Er/Yb silicate slot waveguide amplifier was fabricated and achieved 1.7 dB signal enhancement at 1.53  $\mu\text{m}$  in a waveguide with a 6 mm-long slot pumped at 1476 nm. The Er concentration in the Er/Yb film was confirmed to  $1 \times 10^{21} \text{ cm}^{-3}$ .<sup>22</sup> In this case, the

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optimization of the slot waveguide and the parameters of the active material was not performed, directly leading to a small relative gain that could not meet the requirements of optical communications.

To overcome this issue, accurate optimization must be performed for the slot and the novel active material with a high concentration of  $\text{Er}^{3+}$  dopant. In this work, we synthesized  $\alpha\text{-NaYF}_4\text{:}10\%\text{Er}^{3+}$  nanoparticles (NPs) coated with oleic acid (OA) by a mild hydrothermal process. Then, the  $\text{NaYF}_4\text{:Er}^{3+}$  NPs were copolymerized with methyl methacrylate (MMA) and covalently linked NPs-polymeric methyl methacrylate (PMMA) nanocomposites were synthesized. This material was then filled into the slot as the core layer by spin coating. The modal characteristics, the power confinement, and the minimum effective mode area of the slot were precisely calculated using the full-vector finite difference method. For the slot waveguide with the optimal height of silicon of 250 nm and the width of the silicon and slot length of 222 nm and 100 nm, respectively, the light field confinement factors ( $\Gamma_s$ ) in the slot region for TE polarization were 0.3805 and 0.3862 at 1530 and 1480 nm, respectively. The effective mode area ( $A_{\text{eff}}$ ) values were  $0.0806\ \mu\text{m}^2$  and  $0.0768\ \mu\text{m}^2$  at 1530 and 1480 nm, respectively. A four-level spectroscopic model pumped at 1480 nm was presented. The rate equations and propagation equations were solved, and the gain characteristics of the slot waveguide amplifier were numerically simulated. The primary parameters were optimized. A net gain of 5.78 dB was achieved for a signal power of 0.001 mW at 1530 nm, pump power of 20 mW,  $\text{Er}^{3+}$  concentration of  $1.3 \times 10^{27}\ \text{m}^{-3}$ , and waveguide length of 1.5 cm.

## Optimization of the slot waveguide

### Full-vector finite difference method

The finite element method (FEM) with the intrinsic advantages of restricting individual differences without the need for equipment and environmental variations has been developed into many powerful multi-physical field analysis softwares. Nevertheless, FEM, limited by the difficulty in boundary treatment and the compatibility, has not been well popularized in photonic devices.<sup>23</sup> The effective refractive index method (EIM) is easier to implement, though it is less precise. The finite difference method (FDM) is a numerical method widely used for obtaining the mode profiles of the integrated waveguide devices.<sup>24</sup> The working principle of the finite-difference method is based on the use of finite discrete points divided from the solution domain with a set of differential equations replacing the original differential equations. The finite difference time domain method (FDTD) is a milestone in the history of the development of FDM, while the computation efficiency and memory consumption issues have become problematic.<sup>25</sup> Semi-vectorial finite-difference method (SVFDM) has been used in various numerical analysis studies owing to its simple process and small computational storage requirements but this method ignores the polarization coupling and the conventional difference scheme it is based on is not very suitable for the step-index waveguide. In particular, in the case of a very high difference between the refractive indices of the core layer and the cladding,

the mode profile cannot be reflected exactly by the scalar or semi-vector approaches, and the full-vectorial finite-difference method (FVFDM) must be used to solve the vector wave equations.<sup>26,27</sup> In summary, the slot waveguide supports several models. In this work, the FVFDM based on the Lagrange interpolation of the field was used. For the dielectric optical waveguide with the refractive index distribution  $n(x,y)$ , we assume that the magnetic conductivity is uniform. By incorporating the transparent boundary conditions, a reliable electric mode profile and effective refractive index are obtained. The power confined in the slot and the effective mode area were calculated and analysed to optimize the slot waveguide.

### Optical field distribution of the slot waveguide

The structure of the slot waveguide with vertical sidewalls is shown in Fig. 1. A schematic of the slot with infinite height is shown in Fig. 1(a) and that of the slot with a finite height is shown in Fig. 1(b). Two Si strip waveguides with the same height ( $H_{\text{Si}}$ ) and width ( $W_{\text{H}}$ ) are separated by a slot on SOI with the width  $W_{\text{S}}$ . The novel active material  $\text{NaYF}_4\text{:Er}^{3+}$  NPs-PMMA covalently linked nanocomposites are chosen as the core layer. The  $\alpha\text{-NaYF}_4\text{:}10\%\text{Er}^{3+}$  NPs are first synthesized using a mild hydrothermal method in a water-ethanol-OA mixed solvent system. The surface of NPs is modified by unsaturated functional groups, then copolymerized with methylmethacrylate (MMA). The NPs-PMMA covalently linked nanocomposites are synthesized and embedded into the slot by spin coating. Compared to the active material fabricated using physical doping, the higher concentration of the  $\text{Er}^{3+}$  dopant and the better stability are the prominent advantages of the present approach. The thickness of the active material is  $3\ \mu\text{m}$ . The modal profile should be simulated at both the signal wavelength  $\lambda_{\text{S}}$  (1530 nm) and the pump wavelength  $\lambda_{\text{P}}$  (1480 nm). The refractive index of the core is measured using the ellipsometry method (J. A. Woollam, Co. M 2000). The measured values of the core layer are 1.4853 and 1.4856 at 1530 and 1480 nm, respectively. The refractive indices of Si are 3.4779 and 3.482 at 1530 and 1480 nm, respectively. The refractive indices of  $\text{SiO}_2$  are 1.4442 and 1.4510 at 1530 and 1480 nm, respectively. When the Si strip waveguide with height  $H_{\text{Si}} = 220\ \text{nm}$ , width  $W_{\text{H}} = 250\ \text{nm}$ , and gap region width  $W_{\text{S}} = 100\ \text{nm}$ , the modal profiles and the effective refractive indices ( $N_{\text{eff}}$ ) of the slot waveguide under the condition of TE polarization are simulated at 1530 and 1480 nm, as depicted in Fig. 2(a) and (b), respectively. The optical field distributions of

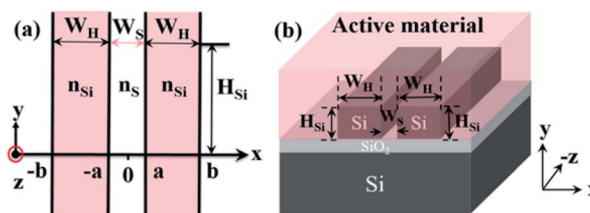


Fig. 1 Schematic of slot waveguide. (a) Schematic of vertical slot with infinite height; (b) schematic of vertical slot with finite height.



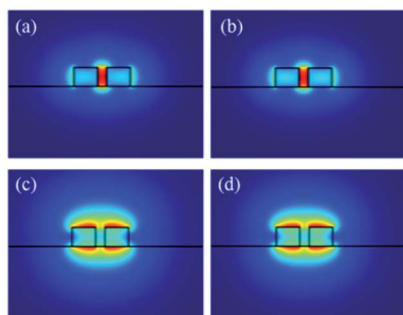


Fig. 2 Characterization of the slot waveguide. (a) Modal profile under TE polarization at 1530 nm; (b) modal profile under TE polarization at 1480 nm; (c) modal profile under TM polarization at 1530 nm; (d) modal profile under TM polarization at 1480 nm.

the slot waveguide under TM polarization in the pump light and signal light wavelengths are shown in Fig. 2(c) and (d).

### Optimization of slot waveguide combined with maximum power confinement in the slot

For a more intuitive view of the ability to confine the light field in the slot, we define the light field confinement factors ( $\Gamma_s$ ) in the slot region for TE and TM polarizations:<sup>28,29</sup>

$$\Gamma_s = \frac{\iint_{\text{slot}} |E(x, y)|^2 dx dy}{\iint_{\text{Total}} |E(x, y)|^2 dx dy} \quad (1)$$

$\Gamma_s$  represents the effective utilization of energy, so we search for a maximum in all the considered cases, which could be used to achieve higher gain. The dependences of  $N_{\text{eff}}$  and  $\Gamma_s$  are simulated at 1530 nm and 1480 nm under TE and TM polarizations on  $W_s$  for  $W_H = 250$  nm and  $H_{\text{Si}} = 250$  nm, as shown in Fig. 3(a) and (b).  $N_{\text{eff}}$  decreases monotonically with increasing  $W_s$ .  $N_{\text{eff}}$  at 1480 nm was slightly larger than the  $N_{\text{eff}}$  at 1530 nm.  $N_{\text{eff}}$  under TE polarization is larger than that under TM polarization and as  $W_s$  increased, the  $N_{\text{eff}}$  under TE polarization decreased faster than that under TM. The confinement factor  $\Gamma_s$  in the slot region at 1480 nm is essentially identical to the  $\Gamma_s$  at 1530 nm and the  $\Gamma_s$  under TE polarization is much higher than the  $\Gamma_s$  under TM polarization. Apparently, the slot guiding structure supports a higher confinement in the slot region for the TE mode than for the TM mode. Both the pump and signal light are confined in the slot under TE polarization and their interaction is enhanced in the slot, which will be beneficial for achieving higher gain. Therefore, in this work, only the TE polarization mode is considered and the TM polarization mode is used for comparison only. Under TE polarization,  $\Gamma_s$  first increases to the maximum value and then decreases, whereas under the TM mode, the  $\Gamma_s$  increases slowly with increasing  $W_s$ .  $N_{\text{eff}}$  and  $\Gamma_s$  show changes with different trends. For small  $W_s$ ,  $\Gamma_s$  increases while  $N_{\text{eff}}$  decreases because more light is confined in the low refractive index slot area. For  $W_s$  increasing past maximum  $\Gamma_s$ , more light will be limited to a low refractive index but not the slot area, with a majority of this light leaking into the cladding, leading to a decrease in both  $N_{\text{eff}}$  and  $\Gamma_s$  with

increasing  $W_s$ . As mentioned above, the electric field confined in the slot region was enhanced greatly due to the strong electric field coupling resonance at the two interfaces in the nanometer slot. Consequently, the advantage of the slot structure will not be significant with increasing  $W_s$  and the high electric field intensity cannot be maintained. Similarly, Fig. 3(c) and (d) show  $N_{\text{eff}}$  and  $\Gamma_s$  as functions of  $W_H$ . The  $N_{\text{eff}}$  and  $\Gamma_s$  values at 1480 nm are close to those at 1530 nm.  $N_{\text{eff}}$  shows a constant linear increase with increasing  $W_H$ . In contrast,  $\Gamma_s$  first increases instantaneously to the maximum value and then decreases gradually. For small  $W_H$ , two strip waveguides cannot confine the light slot and the silicon well, and more light leaks into the cladding. With increasing  $W_H$ , the mode profile leaking into the cladding is gradually assigned to the silicon waveguide and the slot. The  $W_H$  has an optimal value so that upon a further increase in  $W_H$ , a fraction of light is distributed in silicon so that  $N_{\text{eff}}$  increases while  $\Gamma_s$  decreases. Since  $W_H$  does not influence the cross-sectional area of the waveguide, a further increase in  $W_H$  leads to a slow decrease in  $\Gamma_s$ . The relationships of  $N_{\text{eff}}$  and  $\Gamma_s$  with  $H_{\text{Si}}$  are shown in Fig. 3(e) and (f).

### Optimization of slot waveguide combined with minimum effective mode area of the slot

$N_{\text{eff}}$  and  $\Gamma_s$  increase monotonically with the increase in  $H_{\text{Si}}$ . When  $H_{\text{Si}}$  is relatively small, the mode profile at both ends of the slot area has a very high intensity and a majority of the light leaks into the cladding and the substrate. With the increase in  $H_{\text{Si}}$ , the phenomenon of optical field leakage is alleviated. As the height continues to increase, the weak energy at the boundary is confined in the slot, so  $\Gamma_s$  tends to saturate. However, an excessive  $H_{\text{Si}}$  can lead to an increasing loss in the slot waveguide. To comprehensively consider the performance of erbium doped waveguide amplifiers (EDWA) based on the slot, the effective mode area ( $A_{\text{eff}}$ ) is considered to optimize the size of the slot waveguide. We define  $A_{\text{eff}}$  as:<sup>30</sup>

$$A_{\text{eff}} = \frac{(\iint |E(x, y)|^2 dx dy)^2}{\iint |E(x, y)|^4 dx dy} \quad (2)$$

The EDWA based on the slot must have a small effective mode area conducive for achieving gain under low threshold power, where  $E(x, y)$  is the electric field in the entire cross-section of the waveguide. The  $A_{\text{eff}}$  values under TE and TM polarizations are plotted in Fig. 4 at 1530 nm and 1480 nm, respectively. As stated above,  $\Gamma_s$  is predominantly affected by  $H_{\text{Si}}$ . An increase in  $H_{\text{Si}}$  of any amount can increase the  $\Gamma_s$  value to some extent but a practical slot waveguide is formed with a finite height and an excessive height will give rise to superfluous transmission loss and coupling loss; we therefore carry out combined optimization of  $H_{\text{Si}}$  and  $A_{\text{eff}}$ . Fig. 4(a) shows  $A_{\text{eff}}$  as a function of  $H_{\text{Si}}$  at 1530 nm and 1480 nm under TE and TM polarizations, respectively, when  $W_s$  is 100 nm and  $W_H$  is 220 nm. The  $A_{\text{eff}}$  at 1480 nm is close to the  $A_{\text{eff}}$  value at 1530 nm and the  $A_{\text{eff}}$  value under TM polarization is greater than that under TE polarization. The slot under both polarizations has optimal values of  $H_{\text{Si}}$ . Only the TE mode is considered because





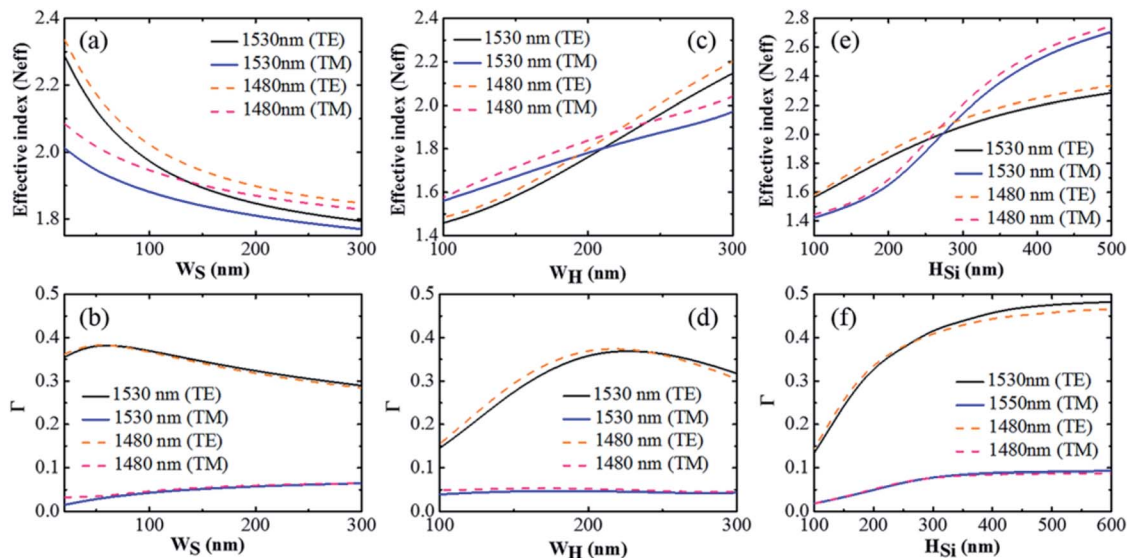


Fig. 3 Optimization of the slot waveguide combined with maximum power confinement in the slot. (a) Dependence of  $N_{\text{eff}}$  at 1530 nm and 1480 nm under TE and TM polarizations on  $W_S$  ( $W_H = 250$  nm,  $H_{\text{Si}} = 250$  nm); (b) dependence of  $\Gamma_S$  at 1530 nm and 1480 nm under TE and TM polarizations on  $W_S$  ( $W_H = 250$  nm,  $H_{\text{Si}} = 250$  nm); (c)  $N_{\text{eff}}$  at 1530 nm and 1480 nm under TE and TM polarizations ( $W_S = 100$  nm,  $H_{\text{Si}} = 250$  nm); (d)  $\Gamma_S$  as a function of  $W_H$  at 1530 nm and 1480 nm under TE and TM polarizations ( $W_S = 100$  nm,  $H_{\text{Si}} = 250$  nm); (e)  $N_{\text{eff}}$  at 1530 nm and 1480 nm under TE and TM polarizations versus  $H_{\text{Si}}$  ( $W_S = 100$  nm,  $W_H = 250$  nm); (f)  $N_{\text{eff}}$  at 1530 nm and 1480 nm under TE and TM polarizations versus  $H_{\text{Si}}$  ( $W_S = 100$  nm,  $W_H = 250$  nm).

of its relatively weak ability to limit the light field and because of the larger  $A_{\text{eff}}$  in the TM mode. Then, the height of the slot was optimized for  $H_{\text{Si}} = 250$  nm. Fig. 4(b) shows the  $A_{\text{eff}}$  at 1530 nm and 1480 nm under TE and TM polarizations versus  $W_S$ , respectively, when  $H_{\text{Si}}$  is 250 nm and  $W_H$  is 220 nm.  $A_{\text{eff}}$  increases monotonically as  $W_S$  increases. Fig. 4(c) shows the  $A_{\text{eff}}$  at 1530 nm and 1480 nm under TE and TM polarizations for different  $W_H$  ( $H_{\text{Si}} = 250$  nm,  $W_S = 100$  nm), respectively. The

variation in  $A_{\text{eff}}$  for different  $W_H$  is analogous to that versus  $H_{\text{Si}}$ . For  $H_{\text{Si}} = 250$  nm, the optimized  $W_H$  values for different  $W_S$  values range between 220 nm and 230 nm, as shown in Fig. 4(d). A smaller  $A_{\text{eff}}$  is obtained for smaller  $W_S$ . However, in actual experiments, polymers with small molecular weights can be filled into the narrow slot, while filling the active polymer with macromolecules is difficult. At present, a slot wider than 100 nm can be well filled. The filling ability of the active polymer can be improved by optimizing the diluent and viscosity. As shown in Fig. 3(b), the width of the slot with 100 nm is optimal and the corresponding optimal  $W_H$  is 222 nm. The light field confinement factors ( $\Gamma_S$ ) in the slot region for TE polarization are 0.3805 and 0.3862 at 1530 and 1480 nm, respectively. The  $A_{\text{eff}}$  of  $0.0806 \mu\text{m}^2$  and  $0.0768 \mu\text{m}^2$  is obtained at 1530 and 1480 nm, respectively.

## Gain characteristics of slot waveguide amplifier

### Four-level spectroscopic model pumped at 1480 nm

The  $\text{Er}^{3+}$ -doped low refractive index material is filled into the slot waveguide and the potential gain of the slot waveguide amplifier is investigated. The gain characteristic analysis supported the optimization of the waveguide based on the  $\text{Er}^{3+}$ -doped four-level system, as shown in Fig. 5 and pumping at 1480 nm was chosen owing to the excessive loss absorption at 980 nm in the silicon layers forming the slot waveguide.<sup>31</sup> To achieve a more accurate simulation, the cooperative up-conversion ( $C_{\text{up}}$ ), cross-relaxation ( $C_{14}$ ), and non-radiative decays ( $A_{43}$ ,  $A_{32}$ ) are involved. The operational principle of the amplifier pumped at 1480 nm is as follows: the  $\text{Er}^{3+}$  ions in the

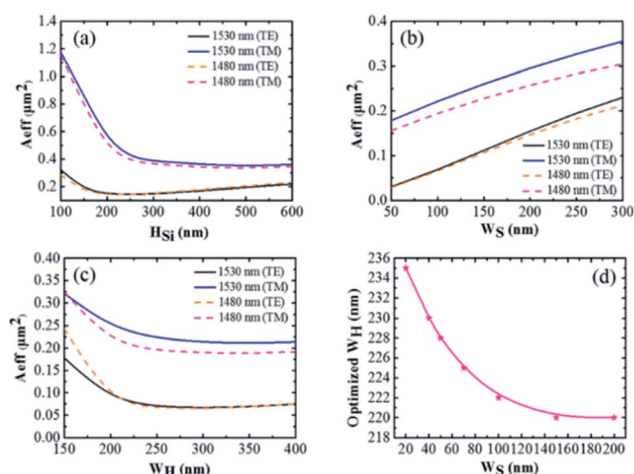


Fig. 4 (a)  $A_{\text{eff}}$  as a function of  $H_{\text{Si}}$  at 1530 nm and 1480 nm under TE and TM polarizations ( $W_S = 100$  nm,  $W_H = 220$  nm), respectively. (b)  $A_{\text{eff}}$  at 1530 nm and 1480 nm under TE and TM polarizations versus  $W_S$  ( $H_{\text{Si}} = 250$  nm,  $W_H = 220$  nm), respectively. (c)  $A_{\text{eff}}$  at 1530 nm and 1480 nm under TE and TM polarizations for different  $W_H$  ( $H_{\text{Si}} = 250$  nm,  $W_S = 100$  nm), respectively. (d) Optimized  $W_H$  for different  $W_S$  ( $H_{\text{Si}} = 250$  nm).



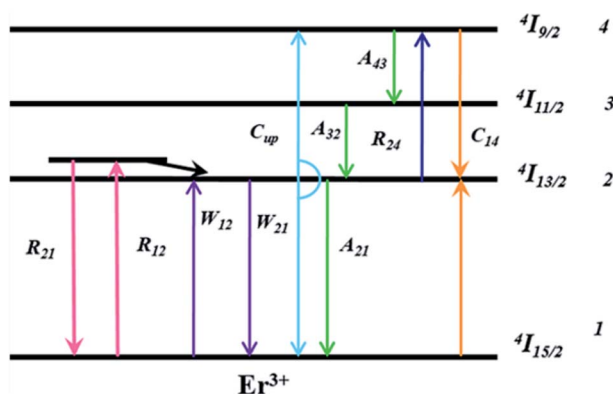


Fig. 5 Energy-level transitions for the  $\text{Er}^{3+}$ -doped four-level system (1480 nm pump).

ground state absorb the pump energy and then transition from the  $^4\text{I}_{15/2}$  level to the higher Stark split sub-levels in the  $^4\text{I}_{13/2}$  excited level. Owing to thermal relaxation,  $\text{Er}^{3+}$  ions rapidly decay to the lower Stark split sub-levels in the  $^4\text{I}_{13/2}$  excited level and remain there longer. When the pump power exceeds the threshold power, population inversion occurs between  $^4\text{I}_{15/2}$  and  $^4\text{I}_{13/2}$ . Then, the  $\text{Er}^{3+}$  ions in the  $^4\text{I}_{13/2}$  level transition down to the ground level  $^4\text{I}_{15/2}$  and emit the photons with the same frequency as that of the signal, so the device realizes the amplification function for the signal. Here, the amplified spontaneous emission (ASE) was neglected. Combined with the analysis of the energy level transitions for  $\text{Er}^{3+}$ -doped four-level system, using the method of overlap integral, the simplified versions of the rate equations are obtained where  $N_1$ ,  $N_2$ ,  $N_3$ , and  $N_4$  are defined as the concentrations of  $\text{Er}^{3+}$  in the  $^4\text{I}_{15/2}$ ,  $^4\text{I}_{13/2}$ ,  $^4\text{I}_{11/2}$ , and  $^4\text{I}_{9/2}$  energy states, respectively.  $N_{\text{Er}}$  is the total  $\text{Er}^{3+}$  ion concentration.

Therefore, the rate equations were established and then solved using a formulated iteration method. The rate equations can be expressed by:

$$\frac{dN_1}{dt} = -(W_{12} + R_{12})N_1 + (W_{21} + R_{21} + A_{21})N_2 + (C_{\text{up}}N_2^2 - C_{14}N_1N_4) \quad (3)$$

$$\frac{dN_2}{dt} = (W_{12} + R_{12})N_1 - (W_{21} + R_{21} + A_{21} + R_{24})N_2 + A_{32}N_3 - 2(C_{\text{up}}N_2^2 - C_{14}N_1N_4) \quad (4)$$

$$\frac{dN_3}{dt} = -A_{32}N_3 + 2A_{43}N_4 \quad (5)$$

$$\frac{dN_4}{dt} = R_{24}N_2 + (C_{\text{up}}N_2^2 - C_{14}N_1N_4) - A_{43}N_4 \quad (6)$$

$$N_1 + N_2 + N_3 + N_4 = N_{\text{Er}} \quad (7)$$

Then, the evolution of the signal and the pump power through the propagation length are described by:

$$\frac{dP_{\text{S}}(Z)}{dz} = [\sigma_{21}(\nu_{\text{S}})N_2 - \sigma_{12}(\nu_{\text{S}})N_1]P_{\text{S}}(Z) - P_{\text{S}}(Z)\alpha_{\text{S}} \quad (8)$$

$$\frac{dP_{\text{P}}(Z)}{dz} = -P_{\text{P}}(Z)\alpha_{\text{S}} - [\sigma_{12}(\nu_{\text{P}})N_1 - \sigma_{21}(\nu_{\text{P}})N_2 + \sigma_{24}(\nu_{\text{P}})N_2]P_{\text{P}}(Z) \quad (9)$$

$\sigma_{12}(\nu_{\text{S}})$  and  $\sigma_{21}(\nu_{\text{S}})$  are the absorption and emission cross-sections of  $\text{Er}^{3+}$  for the signal, respectively,  $\sigma_{12}(\nu_{\text{P}})$  and  $\sigma_{21}(\nu_{\text{P}})$  are the absorption and emission cross-sections of  $\text{Er}^{3+}$  for the pump, respectively, and  $\sigma_{24}(\nu_{\text{P}})$  is the excited state absorption of  $\text{Er}^{3+}$  for the pump.  $h$  is the Planck's constant, and  $\alpha_{\text{S}}$  and  $\alpha_{\text{P}}$  are the loss coefficients. Under steady-state conditions, the population densities maintain the dynamic balances considered in this system. Combining the signal and the pump propagation equations, the gain characteristics were analyzed using the Runge-Kutta method under the conditions of uniform doping and the steady state. The gain  $G$  was defined as follows:<sup>32</sup>

$$G(\text{dB}) = 10 \lg \frac{P_{\text{S}}(Z)}{P_{\text{S}}(0)} \quad (10)$$

It is difficult to test all the parameters of the active polymer used in the simulation accurately. Incorporating the Judd-Ofelt theory, the absorption and emission spectrum are characterized, the parameter values of  $\text{NaYF}_4:\text{Er}^{3+}$  NP-PMMA covalently linked nanocomposites are calculated as shown in Table 1. The maximum concentration of the  $\text{Er}^{3+}$  dopant of this novel material is  $1.3 \times 10^{27} \text{ m}^{-3}$ . The transmission loss of the slot waveguide filled with the active polymer measured by cutback method is about  $9 \text{ dB cm}^{-1}$ . The set of atomic rate equations under the boundary conditions are solved using the formulated iteration method. The gain characteristics are obtained using the Runge-Kutta method combined with the propagation equations. First, the input signal power, pump power, and length of the slot waveguide are optimized by analysing the gain curves, as shown in Fig. 6.

Table 1 Parameter values of  $\text{NaYF}_4:\text{Er}^{3+}$  NP-PMMA covalently linked nanocomposite

Symbol	Full name	Quantity
$\sigma_{12\text{P}}$	Absorption cross section at 1480 nm	$7.53 \times 10^{-25} \text{ m}^2$
$\sigma_{21\text{P}}$	Emission cross section at 1480 nm	$0.6 \times 10^{-25} \text{ m}^2$
$\sigma_{24}$	Excited state absorption cross section	$0.85 \times 10^{-25} \text{ m}^2$
$\sigma_{12\text{S}}$	Absorption cross section at 1530 nm	$3.73 \times 10^{-25} \text{ m}^2$
$\sigma_{21\text{S}}$	Emission cross section at 1530 nm	$8.62 \times 10^{-25} \text{ m}^2$
$A_{21}$	Spontaneous emission rate of $N_2$	$120 \text{ s}^{-1}$
$A_{32}$	Spontaneous emission rate of $N_3$	$1 \times 10^5 \text{ s}^{-1}$
$A_{43}$	Spontaneous emission rate of $N_4$	$1 \times 10^7 \text{ s}^{-1}$
$C_{\text{up}}$	Up-conversion coefficient	$3.2 \times 10^{-24} \text{ m}^3 \text{ s}^{-1}$
Loss_S	Transmission loss of the signal laser	$9 \text{ dB cm}^{-1}$
$C_{14}$	Cross-relaxation coefficient	$1 \times 10^{-23} \text{ m}^3 \text{ s}^{-1}$
Loss_P	Transmission loss of the pump laser	$9 \text{ dB cm}^{-1}$
$N_{\text{Er}}$	Erbium ion density	$1.3 \times 10^{27} \text{ m}^{-3}$
$\Gamma_{\text{S}}$	Overlapping factor of the signal laser	0.38
$\Gamma_{\text{P}}$	Overlapping factor of the pump laser	0.386
$P_{\text{P}}$	Pump power	400 mW



For the pump power of 30 mW, the gain *versus* coordinate length of the slot waveguide for different signal powers is shown in Fig. 6(a). Fig. 6(b) indicates gain as the function of pump power at 1480 nm wavelength for different signal power with 1.5 cm slot waveguide. The effects of different input signal power intensities are shown and it can be seen that the gain increases gradually with decreasing signal power. When the signal power is 0.001 mW, the increase in the gain tends to be saturated. Small signal power is desirable and shows the dependence given by eqn (3). With the pump power increasing, the gain increases to the maximum value and then decreases. There is no saturated gain unlike for the pumping at 980 nm, which is mainly because the influence of the ESA occurs in the  $^4I_{13/2}$  level so that when the pump power exceeds the threshold power, the ions in the  $^4I_{13/2}$  level absorb the pump power and transition up, which decreases the impact on the gain. Therefore, the gain has shown the maximum value at the optimal pump power. Fig. 6(c) shows the gain *versus* the coordinate length of the slot waveguide for different pump power levels. With the input pump power increasing, the gain first increases gradually and then decreases continually, with the optimal pump power of approximately 20 mW. ESA is a detrimental process for amplifier gain and  $R_{24}$  of the material should be reduced. As can be seen, with the length of the slot waveguide increasing at different pump power levels, the gain first increases gradually and then decreases continually, and the length shows an optimum value. When the pump power increases, the gain corresponding to the optimal length also increases. This is because pump power is constantly consumed in the transmission along the waveguide, so after reaching the optimal waveguide length, the pump power is smaller than the threshold power and the amplification shuts off, with transmission loss causing negative gain when the length is too long.

On increasing the input pump power, the pump power will reach the threshold power in the farther transmission direction. During this period, the device keeps amplifying the signal light so that the maximum gain is improved. Upon further increase in the pump power, ESA will decrease the gain. Fig. 6(d) shows the gain as a function of pump power at 1480 nm wavelength for different lengths of the slot waveguide for the signal power of 0.001 mW and pump power of 20 mW. The slot waveguide with 1.5 cm is required.

The concentration of  $\text{Er}^{3+}$  as a significant parameter directly impacts the gain. Fig. 7(a) shows the gain *versus* the coordinate length of the slot waveguide for different  $\text{Er}^{3+}$  concentrations. Fig. 7(b) shows the gain as a function of pump power at 1480 nm wavelength for different  $\text{Er}^{3+}$  concentrations. We can see that the higher the concentration of the material, the larger the gain. When the pump power is 20 mW, the gain increases with increasing  $\text{Er}^{3+}$  concentration and the optimal length decreases with it. When the length of the waveguide is 1.5 cm, the gain increases with increasing  $\text{Er}^{3+}$  concentration and the threshold pumping power also increases. This is because the threshold pumping power represents the minimum pump power for the occurrence of population inversion between the metastable energy level and the ground state energy level. Higher pump power is desired with increasing  $\text{Er}^{3+}$  concentrations. Then, a shorter length is needed for constant pump power. The  $\text{Er}^{3+}$  concentration of  $1.3 \times 10^{27} \text{ m}^{-3}$  is chosen, the corresponding optimal length is approximately 1.5 cm, and the optimal pump power is 20 mW, both of which are in agreement with the values obtained by the above-described optimization. The higher  $\text{Er}^{3+}$  concentration is still expected and the novel active material  $\text{NaYF}_4:\text{Er}^{3+}$  NP-PMMA allows the concentration of the  $\text{Er}^{3+}$  dopant an order of magnitude higher compared to the material obtained by physical doping, while the beneficial  $\text{Er}^{3+}$

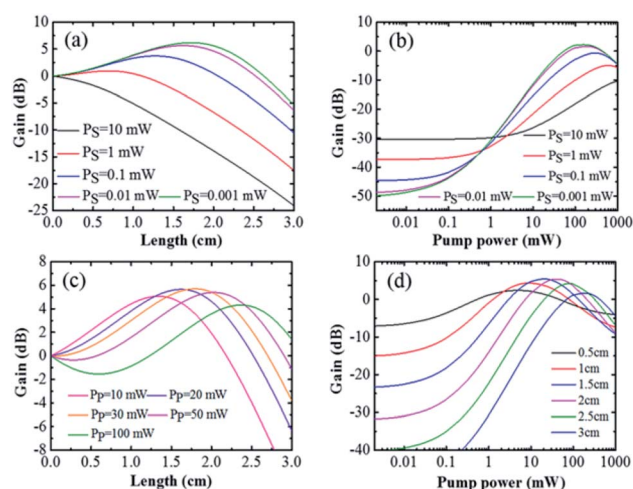


Fig. 6 (a) Gain *versus* coordinate length of the slot waveguide for different signal powers. (b) Gain as a function of pump power at 1480 nm wavelength for different signal powers. (c) Gain *versus* coordinate length of slot waveguide for different pump powers. (d) Gain as a function of pump power at 1480 nm wavelength for different lengths of the slot waveguide.

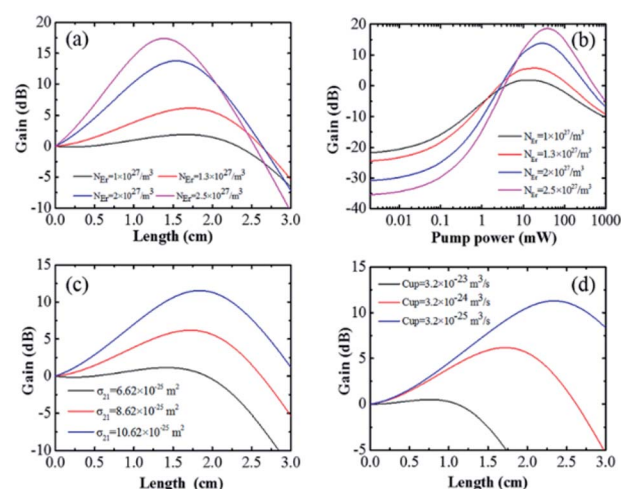


Fig. 7 (a) Gain *versus* coordinate length of the slot waveguide for different  $\text{Er}^{3+}$  concentrations. (b) Gain as a function of pump power at 1480 nm wavelength for different  $\text{Er}^{3+}$  concentrations. (c) The gain *versus* coordinate length of the slot waveguide for different signal emission cross-sections. (d) Gain as a function of pump power at 1480 nm wavelength for different up-conversion coefficients.





concentration presents an interesting improvement in the synthesis of the active material. Fig. 7(c) shows the gain plotted *versus* the coordinate length of the slot waveguide for different signal emission cross-sections. The intensity of the signal emission cross-sections plays a highly important role in the amplification of signal light and for a small change in the emission cross-section of the signal photons, the gain could be highly depleted. In our work, the emission cross-section calculated by Judd–Ofelt theory is  $8.62 \times 10^{-25} \text{ m}^2$ . The active material with larger emission cross-section is expected. Fig. 7(d) shows the gain as a function of pump power at 1480 nm wavelength for different up-conversion coefficients. The physical mechanism of the up-conversion is as follows: an excited ion in  $^4\text{I}_{13/2}$  gives its energy to another excited ion in the same state level and excites it to the higher energy level  $^4\text{I}_{19/2}$ . A significant depopulation of the ions in  $^4\text{I}_{13/2}$  occurs, breaking the population inversion and reducing the gain. We can see from Fig. 7(d) that the gain decreases greatly with increasing up-conversion coefficient. The conversion coefficient is proportional to the  $\text{Er}^{3+}$  concentration. The doping of high  $\text{Er}^{3+}$  concentration will cause large conversion coefficient. When the pump power is constant, the optimal length decreases with increasing up-conversion coefficient. A homogeneous distribution of  $\text{Er}^{3+}$  can be useful in reducing the up-conversion.

The gain *versus* coordinate pump power for different heights of silicon, widths of silicon, and widths of the slot were calculated using the optimized parameters, as shown in Fig. 8(a)–(c). When the width of silicon was 220 nm, the slot waveguide amplifier achieved the maximum gain. The height of the silicon was still the determining factor for the gain. Larger gain was achieved for greater height of silicon. The supererogatory transmission loss was not considered. A narrower slot is beneficial for acquiring larger gain with lower threshold pump power, while not considering the difficulty involved in the filling

of the active material. The simulation results were consistent with the results of the above-described optimization. The slot waveguide amplifier achieved 5.78 dB net gain under TE polarization in a 1.5 cm waveguide when the height of silicon was 250 nm, the width of silicon was 220 nm, and the width of the slot was 100 nm. The propagation loss of the slot waveguide will be reduced by optimizing the fabrication technology and the net gain will be improved to a higher value.

## Conclusions

In conclusion,  $\text{NaYF}_4:\text{Er}^{3+}$  NPs-PMMA covalently linked nanocomposites were synthesized by copolymerization of  $\text{NaYF}_4:\text{Er}^{3+}$  nanoparticles with methyl methacrylate. The stability and the concentration of the  $\text{Er}^{3+}$  dopant have been improved. This material was filled into the slot as the core layer. The full-vector finite difference method was demonstrated for the optimization of the slot waveguide by the precise analysis of power confinement and the minimum effective mode area of the slot. The modal characteristics under TE and TM polarizations were described. The slot guiding structure supported a higher TE mode confined in the slot region compared to the TM mode. When the slot waveguide had an optimal silicon height of 250 nm, a silicon width of 222 nm, and a slot width of 100 nm, the light field confinement factors ( $\Gamma_s$ ) in the slot region for TE polarization were 0.3805 and 0.3862 at 1530 and 1480 nm, respectively. The effective mode area ( $A_{\text{eff}}$ ) values were  $0.0806 \mu\text{m}^2$  and  $0.0768 \mu\text{m}^2$  at 1530 and 1480 nm, respectively. A four-level spectroscopic model pumped at 1480 nm was presented. The rate equations and propagation equations were solved, and the gain characteristics of the slot waveguide amplifier were numerically simulated. The primary parameters were optimized. A net gain of 5.78 dB was achieved for the signal power of 0.001 mW at 1530 nm, pump power of 20 mW,  $\text{Er}^{3+}$  concentration of  $1.3 \times 10^{27} \text{ m}^{-3}$ , and waveguide length of 1.5 cm.

## Conflicts of interest

The authors declare no competing interests.

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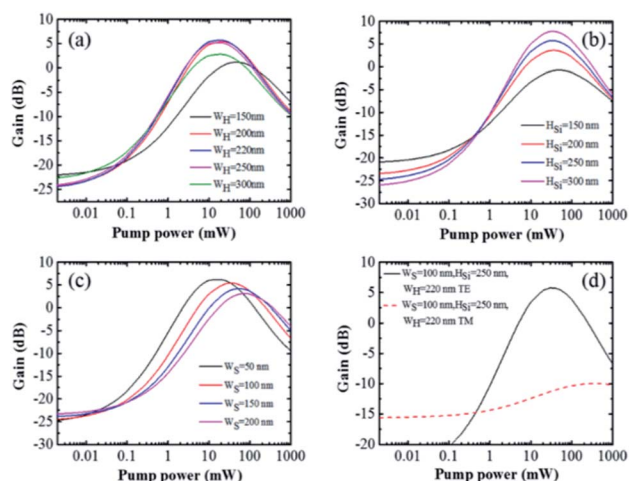


Fig. 8 (a) Gain *versus* coordinate pump power for different widths of silicon. (b) Gain *versus* coordinate pump power for different heights of silicon. (c) Gain *versus* coordinate pump power for different widths of the slot. (d) Gain as a function of pump power under TE and TM polarizations ( $W_s = 100 \text{ nm}$ ,  $H_{\text{Si}} = 100 \text{ nm}$ ,  $W_H = 100 \text{ nm}$ ).



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